Room Temperature Sputter-deposited Co-Cr Film

AIT (Akita Research Institute of Advanced Technology)

I. Magnetic properties and crystal orientation

II. Microstructure

A. Effect of Ar pressure

B. Cr segregation and microstructure model

References

- N. Honda, K. Ouchi and S. Iwasaki, Journal of Applied Physics, vol.75(10), 5984 (1994)
 N. Honda, J. Ariake, K. Ouchi and S. Iwasaki, Abstracts of the 6th Joint MMM-Intermag Conf., GP-05 (1994)